



Microsystems for Space and Defense Applications

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Message from the Guest Editors

Dear Colleagues,

Following the success of our previous Special Issue in 2020 (*Miniaturized Pyro Devices*), we are pleased to announce a further Special Issue of *Micromachines* dedicated to the latest research in optical trapping, to be titled “Microsystems for Space and Defense applications” and scheduled for publication in 2021.

The Special Issue will accept diverse forms of contributions, including research papers, communications, methods, and review articles that represent high-quality, fundamental and applied research relating to Space and Defence technologies.

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Guest Editors





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Message from the Editor-in-Chief

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